



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Shrinivasan et al.

Attorney Docket No.:  
NOVLP029/NVLS-000495

Application No.: 10/067,520

Examiner: Not yet assigned

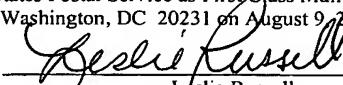
Filed: February 5, 2002

Group: 2811

Title: APPARATUS AND METHODS FOR  
PROCESSING SEMICONDUCTOR  
SUBSTRATES USING SUPERCRITICAL  
FLUIDS

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as First Class Mail to: Commissioner for  
Patents, Washington, DC 20231 on August 9, 2002.

Signed: 

Leslie Russell

**INFORMATION DISCLOSURE STATEMENT**  
37 CFR §§1.56 AND 1.97(b)

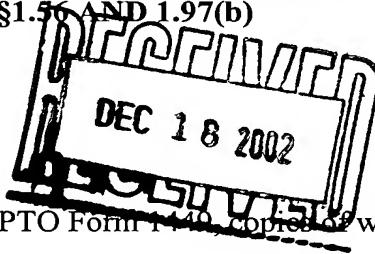
Commissioner for Patents  
Washington, DC 20231

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

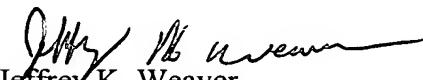
This Information Disclosure Statement is: (i) filed within three (3) months of the filing date of the above-referenced application, (ii) believed to be filed before the mailing date of a first Office Action on the merits, or (iii) believed to be filed before the mailing of a first Office Action after the filing of a Request for Continued Examination under §1.114. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure



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Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. NVLSP029).

Respectfully submitted,  
BEYER WEAVER & THOMAS, LLP

  
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**Form 1449 (Modified)**
**Information Disclosure  
Statement By Applicant**

(Use Several Sheets if Necessary)

 Atty Docket No. NOVLP029/NVLS-000495 Application No.: 10/067,520  
 Applicant: Shrinivasan et al.  
 Filing Date February 5, 2002 Group 2811

**U.S. Patent Documents**

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A1						
	A2						
	A3						
	A4						
	A5						
	A6						
	A7						
	A8						
	A9						

**Foreign Patent or Published Foreign Patent Application**

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	B1	WO02/01947	01/31/02	WIPO				
	B2	WO01/46999	06/28/01	WIPO				
	B3	WO01/33615	05/10/01	WIPO				
	B4	WO01/33613	05/10/01	WIPO				

**Other Documents**

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1	
	C2	
	C3	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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